

Electronic Patent Application Fee Transmittal

Application Number:	10589511			
Filing Date:	15-Aug-2006			
Title of Invention:	Method for cleaning treatment chamber in substrate treating apparatus and method for detecting endpoint of cleaning			
First Named Inventor/Applicant Name:	Shigenori Ozaki			
Filer:	Marvin Jay Spivak/Ashley Lundsten			
Attorney Docket Number:	295037US26PCT			
Filed as Large Entity				
U.S. National Stage under 35 USC 371 Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				
Extension - 1 month with \$0 paid	1251	1	130	130

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Total in USD (\$)				130